

Serial No. 09/935,699  
Docket No. T36-135964M/RS

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Uemura et al.

Serial No.: 09/935,699

Group Art Unit: 1733

Filed: August 24, 2001

Examiner: Kornakov, Michail

For: METHOD FOR MANUFACTURING A GROUP III NITRIDE COMPOUND  
SEMICONDUCTOR DEVICE

Honorable Commissioner of Patents  
Alexandria, VA 22313-1450  
Box AF

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**RESPONSE AND**  
**REQUEST FOR RECONSIDERATION**

*Do not enter*  
*M.K. 12/01/05*

Sir:

In response to the Office Action dated August 23, 2005, Applicant states as follows:

**REMARKS**

Claims 21-24 and 31-38 are all the claims presently pending in the application.

Claims 21-23, 32 and 34-38 stand rejected under 35 U.S.C. § 102(b) as allegedly being anticipated by Maniar et al. (U. S. Patent No. 5,525,542). Claim 31 stands rejected under 35 U.S.C. § 102(b) or alternatively under 35 U.S.C. § 103(a) as allegedly being unpatentable over Maniar. Claim 33 stands rejected under 35 U.S.C. § 103(a) as allegedly being unpatentable over Maniar.

These rejections are respectfully traversed in view of the following discussion.

**I. THE CLAIMED INVENTION**

The claimed invention, as recited in claim 21, is directed to a method for manufacturing a group III nitride compound semiconductor device, including irradiating a